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J. Krause-Polstorff

PATENT APPLICATION

Attorney Docket No. D/9877913

C82874  
#2/I.D.S.

1-7-00

EBJ

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: **Michael A. Kneissl et al.**

Application No.: **09/277,328**

Group Art Unit: **2874**

Filing Date: **3/26/1999**

Examiner: **Not Yet Assigned**

For: **METHOD FOR NITRIDE BASED LASER DIODE WITH GROWTH SUBSTRATE REMOVED**

**INFORMATION DISCLOSURE STATEMENT  
TRANSMITTAL LETTER UNDER 37 CFR 1.97(b)**

Assistant Commissioner for Patents  
Washington, D. C. 20231

Sir:

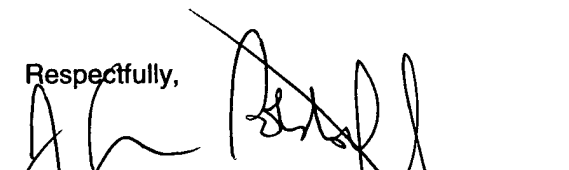
Pursuant to 37 C.F.R. 1.56 and 1.97(b), the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. One copy of each listed reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

The accompanying Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits.

No certification or fee is required.

☐ A non-English language reference is enclosed. Per 37 CFR 1.98(a)(3) a copy of a foreign search report citing this reference or other concise explanation of relevance thereof is attached.

Respectfully,

  
\_\_\_\_\_  
**J. Krause-Polstorff**  
Signature under 37 CFR 1.33 & 34  
Registration No. 41,127  
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☒ Attachment: PTO 1449 and copies of listed references